Vers			114			T	Semiconductor and Elec				100000000000000000000000000000000000000	gy	Vers		16	117	
	Year		114 FEB 2026		2026	-	Year	115 . FEB 2027		116 SEP 2027			Year		116 FEB 2028		P 202
	Course						Course		,		,		Course				
		Cr.	hr.	Cr.	hr.			Cr.	hr.	Cr.	hr.			Cr.	hr.	Cr.	1
	Physical Education	2	2	2	2			-		_	-		Technical English(III)(IV)	2	2	2	+
	Technical English(I)(II)	2	2	2	2	77.11							Taiwanese Society	2	2		-
	chinese tutoring	0	5	-	-			-			-		Taiwanese Art			2	+
	Chinese Pinyin Pronunciation Practice	1	2														
	Chinese Listening Practice	1	2												. 1		
UST Core	Chinese Conversation Practice	1	2			MUST Core						MUST Core			-		
Required Courses	Chinese Reading and Comprehension	1	2			Required Courses						Required Courses					
Codrises	Chinese Writing Practice	1	2			Courses						Courses	н		- 1		
	Chinese Literature			3	3												
	Chinese Culture			3	3												
	Taiwanese Culture			2	2				W								T
	Taiwan Life and Law			2	2												
	Subtotal	9	19	14	14		Subtotal	0	0	0	0		Subtotal	4	4	4	I
													Ethics for Engineers			2	T
School						School						School			-		T
ofessional Required						Professional Required						Professional Required					Г
Courses						Courses						Courses					Т
	Subtotal	0	0	0	0		Subtotal	0	0	0	0		Subtotal	0	0	2	T
	Physics	3	3				Lab of Property Practice	9	32	9	32		Introduction to Modern Science	3	3		L
	Applied Mathematics	2	2					_					Semiconductor Material and Device Electronics Lab(II)	3	3	_	+
	Basic Circuit Theory	2	2	_	-							0.10000000	Laser Engineering	3	3	_	+
mpulsory	Introduction to Semiconductor and Photonics	2	2			compulsory						compulsory		-	- 5	3	+
courses	Computer Data Processing Electronics Circuits	-	-	3	3	courses		-		_		courses	Optoelectric Lab Semiconductor Manufacturing			3	╁
	Electronics Cab(I)	-	-	3	3				-				Control addition wantard turning			-	t
	Geometrical Optics			3	3										110		I
	Subtotal	9	9	12	12		Subtotal	9	32	9	32		Subtotal Certification of Solid Design CAD and	9	9	9	F
	Vacuum Technology			2	2		Material Science and Engineering	2	2				License Counseling	3	3.		
	Introduction to Bio-Medical Engineering			2	2		Introduction to Computers	2	2				Optical Thin Film and Coating	3	3		Τ
	Engineering Applied Mathematics	-	_	2	2		and Programming Solid State Lighting	2	2	-	-		Technology Technology Management	3	3	_	+
	Introduction and Application of Artificial		-	3	3		Thin Film Technology	2	2				Photonics applications	3	3	-	t
	Intelligence Introduction to Semiconductor Materials	_					Thin Fill Technology		12.4				Priotorics applications		-		+
	Introduction to Semiconductor Materials Industry			3	3		Vision optics	2	2				Thin Film Technology	3	3		
	Material Science and Engineering			2	2		Micro-computer Application	3	3				Semiconductor Inspection technology	3	3		Т
			-	-	-235					-	-		Semiconductor Manufacturing	3	3	-	$^{+}$
							Mobile Computing Practice	3	3				Equipement				1
		-	-	_	_		App Programming Practical Vacuum Technology	3	3	-	-		Certification of Solid Design CAD Nanomaterials	3	3		+
				_			Surface Engineering and Al Assistance	3	3				Computer-Aided Optical System Design	3	3		†
							Introduction of Flat Panel Displays	3	3		Spalls describe		Semiconductor Packaging Process and	3	3		Τ
		-	-		-		CAD of Solid Design	-		2	2		Equipment Data Science		-	3	+
										2	2		Optoelectronic Device and Application			3	t
Elective		-	-	-	_	Elective	Introduction to Artificial Intelligence	-		100	-	Elective				_	+
Courses						Courses	Engineering statistics			2	2	Courses	Solar Photovoltaic Technology		:	3	1
							Chromatics			2	2		Digital Logic Design			3	+
			_	-			Light - Emitting - Diode Technology Measurement of LEDs	-		2	2		Python Application Memory Device Technology			3	+
							Solar Photovoltaic Technology			2	2		Semiconductor Lab		- 42	3	İ
													Semiconductor Manufacturing Equipement			3	ſ
		-											CAD of Solid Certification			3	t
					1		1		-				Semiconductor Materials and Applications	-	-	3	+
			-	-									Commonitude interestate and Applications		- 61		+
													Photonic Biomedical Engineering			3	
													Photonic Biomedical Engineering			3	+
													Computer-Assisted lighting system design		20	3	+
													Computer-Assisted lighting system design Optical Factory		8	3	
						Ü							Computer-Assisted lighting system design Optical Factory Silicon Nano-device Detection and Analysis			3 3	+
													Computer-Assisted lighting system design Optical Factory			3	
													Computer-Assisted lighting system design Optical Factory Silicon Nano-device Detection and Analysis			3 3	

Year			17	118		
	Course	FEB	2029	SEP 2029		
		Cr.	hr.	Cr.	hr.	
MUST Core						
Required						
Courses	Subtotal	0	0	0	0	
School Professional	4 (3.5) 4 (20) (4 (4.5) (4.5) (4.5) (4.5) (4.5) (4.5) (4.5) (4.5) (4.5) (4.5) (4.5) (4.5) (4.5) (4.5) (4.5) (4.5)				200	
Required Courses	Subtotal	0	0	0	0	
compulsory courses	Subtotal	0	0	0	0	
	Lab of Property Practice(III)(IV)	9	32	9	32	
	Project of Optoelectronics	3	3	3	3	
	Solar Photovoltaic Technology	3	3	-	_	
	Optoelectronic Detection Engineering	3	3			
	Chromatics	3	3			
	Artificial Intelligence-Deep Learning	3	3			
Elective	Labview Programming Design	3	3			
Courses	Python Program Application	3	3			
	Machine Learning with Python	3	3			
	Generative AI and Applications	3	3			
	spectral analysis	3	3			
	Creative Design in Optoelectronics			3	3	
	Nano Bio-Photonics			3	3	
	Please:		100	3	3	

Cr./hr.=Credit/hour

Remarks:

- 1.Minimum credits required for graduation: 128 credits including_90_compulsory credits, and at least_38_ elective credits(including the interdepartmental elective credits).

 2.For off-campus internship courses, please follow the relevant implementation regulations.

 3. Off-campus practice courses: Lab of Property Practice(!)(II)(III)(IV), 1 credit requires no more than 80 hours. The actual internship hours for Lab of Property Practice(!)(II) are 38 to 40 hours per week, and the actual internship hours for Lab of Property Practice (III) and (IV) are 32 to 40 hours per week.
- 4.The elective courses listed in the tables are subejet to adaptation when necessary. 5.This form created in _02.19 2025_.







